

IN THE UNITED STATES

PATENT AND TRADEMARK OFFICE

APPLICANTS:

DANIEL MEISBURGER, ET AL.

APPLICATION NO.:

09/502.120

FILING DATE:

FEBRUARY 10, 2000

TITLE:

INSPECTING OPTICAL MASKS WITH ELECTRON BEAM

MICROSCOPY

EXAMINER:

KIET NGUYEN

GROUP ART UNIT:

2881

ATTY. DKT. NO.:

22120-04764

CERTIFICATE OF MAILING

Thereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below:

Dated:

Bv:

Laura A. Majerus, Reg. No. 23,417

COMMISSIONER FOR PATENTS P.O. BOX 1450 **ALEXANDRIA, VA 22313-1450**

NOTICE OF APPEAL

SIR:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Primary Examiner, mailed March 31, 2003, finally rejecting all claims and objecting to all drawings.

Pursuant to 37 CFR § 1.17(e), enclosed is payment in the amount of \$730.00 for the filing of the Notice of Appeal, plus 2-month extension.

Respectfully submitted,

DANIEL MEISBURGER, ET AL.

Dated: August 14, 2003

120.05 DA

United Building (600014) and Palan

Laura A. Majerus, Reg. No. 33,4

Fenwick & West LLP

Silicon Valley Center 801 California Street

Mountain View, CA 94041

Tel.: (650) 335-7152 Fax.: (650) 938-5200